

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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| Applicant  | : Hackenberger et al.  | Art Unit  | : 2891             |
| Serial No. | : 10/599,949   | Examiner  | : Caridad Everhart |
| Filed      | : July 16, 2007  | Conf. No. | : 7071             |
| Title      | : PROCESS FOR STRUCTURING AT LEAST ONE LAYER AS WELL AS<br>ELECTRICAL COMPONENT WITH STRUCTURES FROM THE LAYER |           |                    |

**MAIL STOP AF**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

AMENDMENT IN REPLY TO ACTION OF NOVEMBER 13, 2009

Please amend the above-identified application as follows: